IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Jae-han CHA	I hereby certify that this Patent Application Transmittal and the
Serial No.: To be assigned	documents referred to as enclosed therewith are being deposited with the
Filed: July 29, 2003 (herewith)	 United States Postal Service on July 30, 2003, in an envelope addressed
For: METHOD FOR FABRICATING BiCMOS TRANSISTOR	to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313- 1450 utilizing the "Express Mail Post
Group Art Unit: To be assigned	Office to Addressee" service of the United States Postal Service under Mailing Label No. EV323773443JUS.
Examiner: To be assigned	} Uhall
	Richard Zimmermann

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Submitted herewith for consideration by the examiner is a copy of the document identified on the attached PTO SB/08. Entry and consideration of the submitted document is solicited.

The Commissioner is authorized to charge any fee deficiency required by this paper, or credit any overpayment, to Deposit Account No. 13-2855.

Respectfully submitted,

MARSHALL, GERSTEIN & BORUN LLP 6300 Sears Tower 233 South Wacker Drive

Chicago, Illinois 60606-6357

(312) 474-6300

July 30, 2003

By:

Michael R. Hull

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	INFORMATION DISCLOSURE STATEMENT BY APPLICANT (use as many sheets as necessary)			Application Number	To be assigned	
IN				Filing Date	July 29, 2003 (herewith)	
S				First Named Inventor	Jae-han CHA	
-				Art Unit	To be assigned	
				Examiner Name	To be assigned	
Sheet	1	of	1	Attorney Docket Number	29925/39488	

	U.S. PATENT DOCUMENTS				
Examiner Initials*	Cite No.1	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear

	FOREIGN PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T⁰

¹ Applicant's unique citation designation number (optional). ² See attached Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the application number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁸ Applicant is to place a check mark here if English language Translation is attached.

OTHER PRIOR ART - NON PATENT LITERATURE DOCUMENTS				
Examiner Initials	itom/hook magazina jauraal carial aumagajum gatalag ata) data naga/a) yakuma jagua nur		T ²	
-		Kinoshita et al., "Process Integration Technology for sub-30 ps ECL BiCMOS using Heavily Boron Doped Epitaxial Contact (HYDEC)," <i>Electron Devices Meeting</i> , 1994. <i>Technical Digest</i> , <i>International</i> , 11-14 Dec 1994 pp. 441-444.		

Examiner	Date	
Signature	Considered	

^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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